

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :  
Daisuke INOMATA : Mail Stop Patent Applications  
Serial No. [NEW] : Atty Docket No. OKI.385D  
Filed: July 31, 2003 :  
For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE

**PRELIMINARY AMENDMENT**

U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, **Mail Stop Patent Applications**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

Prior to the examination of the above-identified application, please enter  
the following amendments and consider the following remarks:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which  
begins on page 3 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.